

Figure 1. Complete carbon removal from MO-Mo film, but insufficient resistivity reduction after reduction

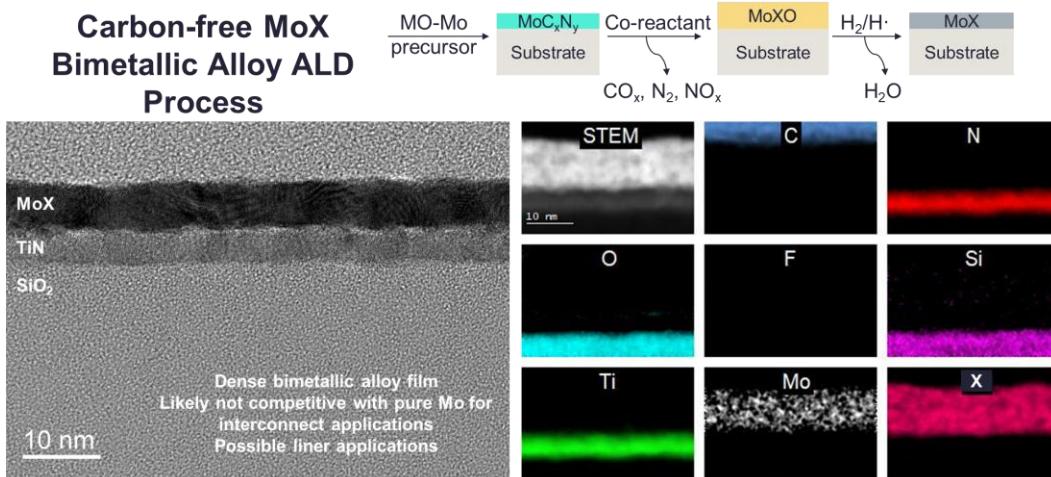


Figure 2. New ALD process for carbon-free bimetallic alloy from a MO-Mo precursor.